



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Sadayoshi HORII et al.

Group Art Unit: 1792

Application No.: 10/529,466

Examiner: R. BUEKER

Filed: March 29, 2005

Docket No.: 123373

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE
PROCESSING APPARATUS

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the November 13, 2007 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.